

10/538901

JC17 Rec'd PCT/PTO 14 JUN 2005
PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Hideyuki Ohsima)	Group Art Unit
)	
Serial No.	:	New U.S. National Stage)	
		Application)	
)	
Filed	:	International Filing Date)	
		December 18, 2003)	
)	
For	:	SEMICONDUCTOR TEST)	
		APPARATUS)	
)	
Examiner	:	Unknown)	
)	

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner
of Patents and Trademarks
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is a form PTO-1449 listing four references relevant to the above-identified application. A copy of the references is also enclosed herewith.

This information disclosure statement is filed at the time of filing the instant application concurrently herewith, therefore, no fee is required under 37 CFR 1.97(b)(1).

All of the references are cited in the International Search Report issued by Japanese Patent Office in the international stage of this case. An English version of the International Search Report is also enclosed. For the prior art references that are not in English, an English abstract is attached to each of the references when it is readily available.

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Serial No. : New National Stage Application
Filed : PCT Filing Date; December 12, 2003

Applicant respectfully requests that the prior art references submitted be considered in the substantive examination of this application.

Respectfully submitted,

MURAMATSU & ASSOCIATES

Dated: 6/14/05

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